

# Semiconductors

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# Why can we ignore e-e interactions?

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With interactions, the energy would depend not just on whether a state is occupied or not, it would also depend on whether the other states are occupied.

# Phonon calculation

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1. Write down the classical equations of motion.
2. Linearize the equations
3. The solutions of the linear equations or eigenfunctions of the translation operator. They decouple into normal modes.
4. Quantize the normal modes separately.

# Landau theory of a Fermi liquid

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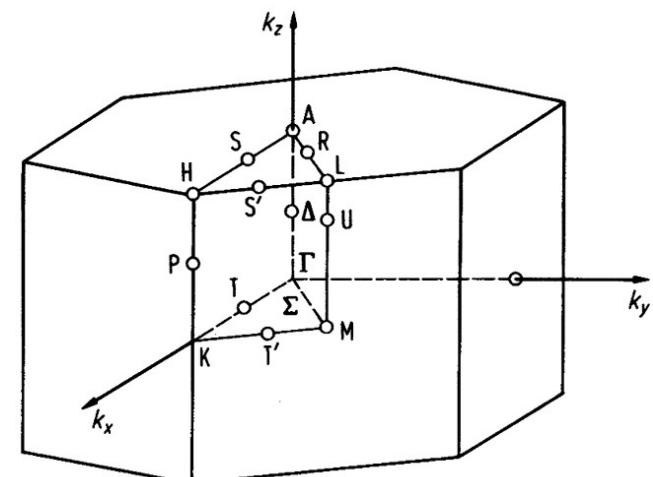
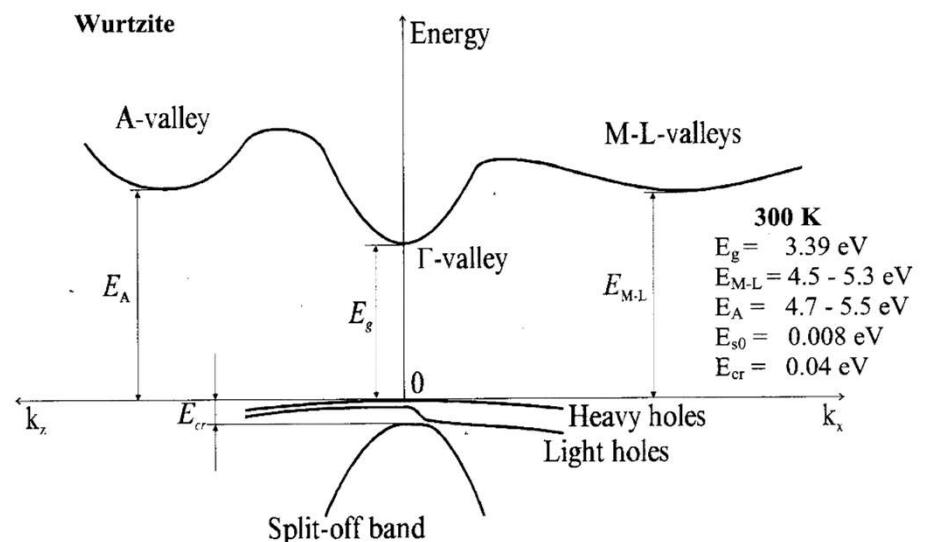
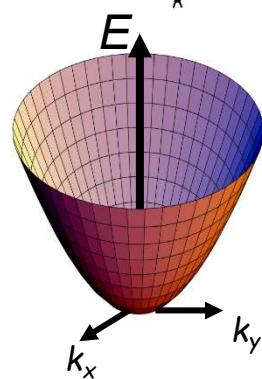
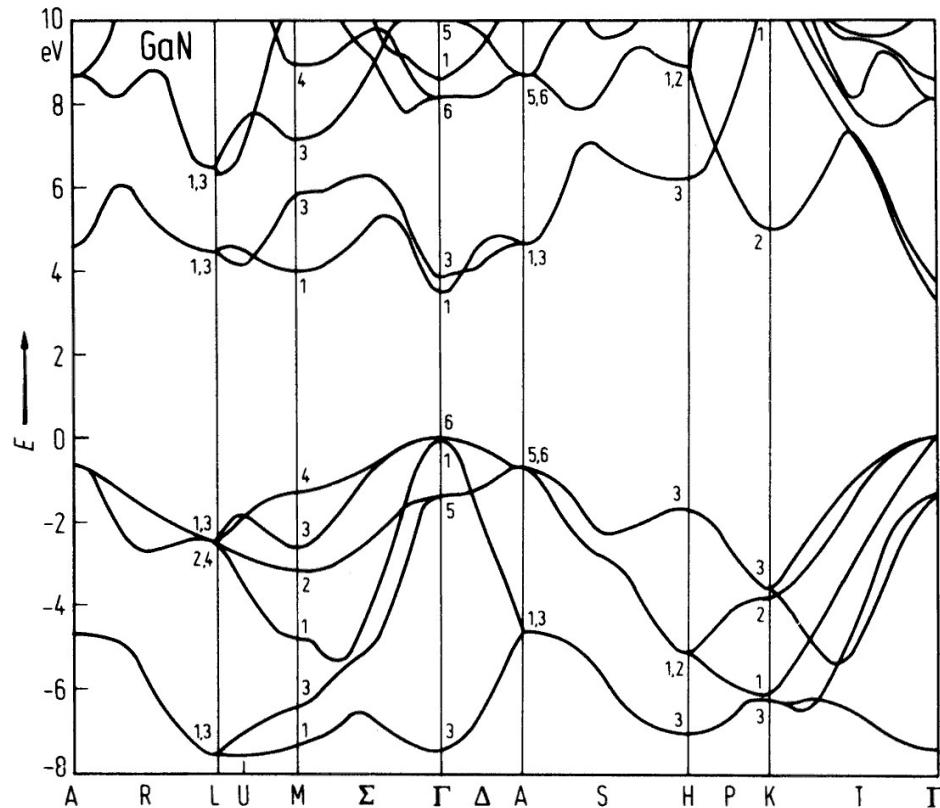
Landau first considered small displacements of the electrons from the many-electron ground state. The "normal modes" of this interacting electron system. The low lying excitations he called quasiparticles.

The quasiparticles have as many degrees of freedom as the electrons. They can be labeled by  $k$ .

Quasiparticles can be have the same spin, charge, and  $k$  vectors as the electrons.

Concepts like the density of states refer to quasiparticles.

# GaN



1st Brillouin zone of hcp

# Free electron Fermi gas

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1 - d

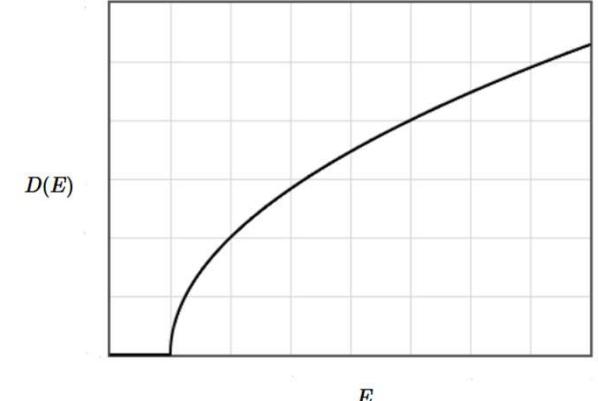
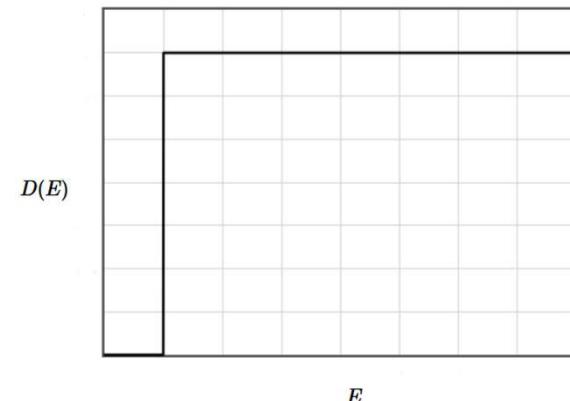
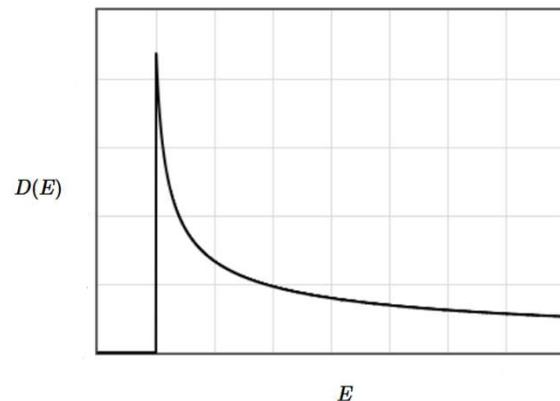
$$D(E) = \sqrt{\frac{2m}{\hbar^2 \pi^2 E}} = \frac{n}{2\sqrt{E_F E}} \quad \text{J}^{-1}\text{m}^{-1}$$

2 - d

$$D(E) = \frac{m}{\hbar^2 \pi} = \frac{n}{E_F} \quad \text{J}^{-1}\text{m}^{-2}$$

3 - d

$$D(E) = \frac{\pi}{2} \left( \frac{2m}{\hbar^2 \pi^2} \right)^{3/2} \sqrt{E} = \frac{3n}{2E_F^{3/2}} \sqrt{E} \quad \text{J}^{-1}\text{m}^{-3}$$



# Measuring the effective mass

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Cyclotron resonance       $\omega_c = \frac{eB}{m^*}$

Resonant absorption occurs when rf waves with the cyclotron resonance frequency are applied. This can be used to experimentally determine the effective mass.

Knowing the effective mass, the scattering time can be calculated from the measured conductivity.

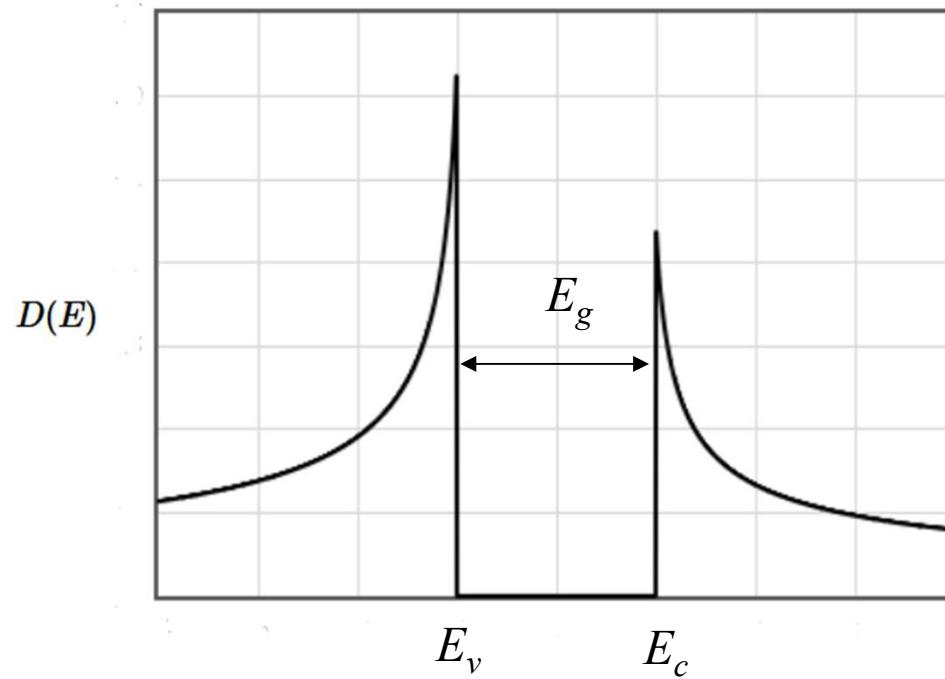
$$\sigma = \frac{ne^2\tau_{sc}}{m^*}$$

# Semiconductors and insulators - 1d

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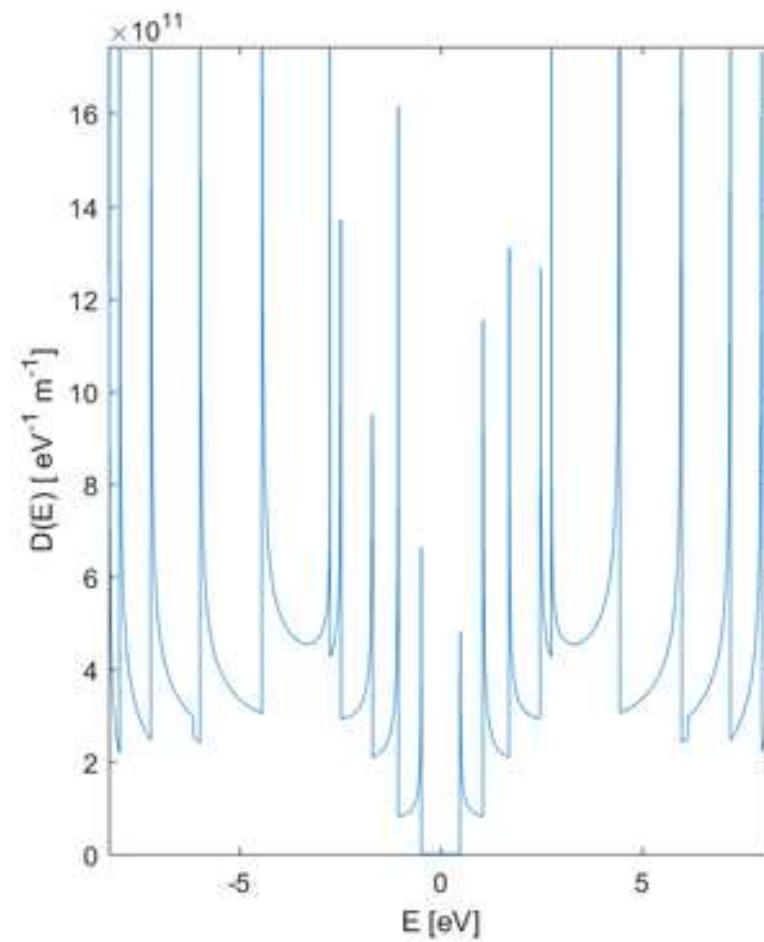
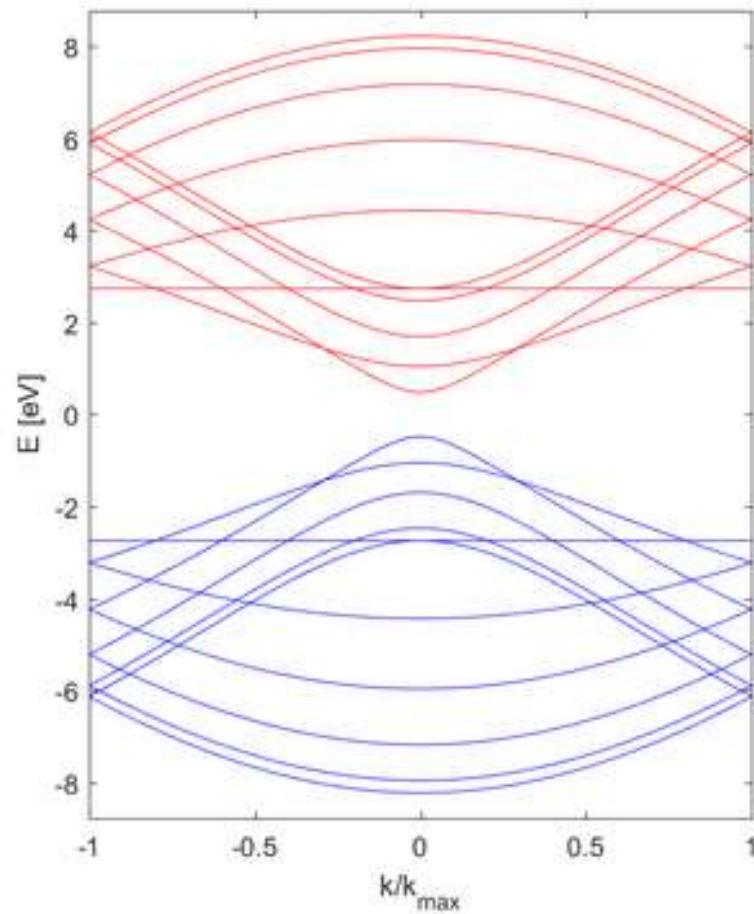
$$E = \frac{\hbar^2(\vec{k} - \vec{k}_0)^2}{2m^*}$$

$$D(E) = \begin{cases} \frac{D_c}{\sqrt{(E_v - E)}} & E < E_v \\ 0 & E_v < E < E_c \\ \frac{D_v}{\sqrt{(E - E_c)}} & E_c < E \end{cases} \text{ J}^{-1}\text{m}^{-3}$$



# Semiconducting carbon nanotubes

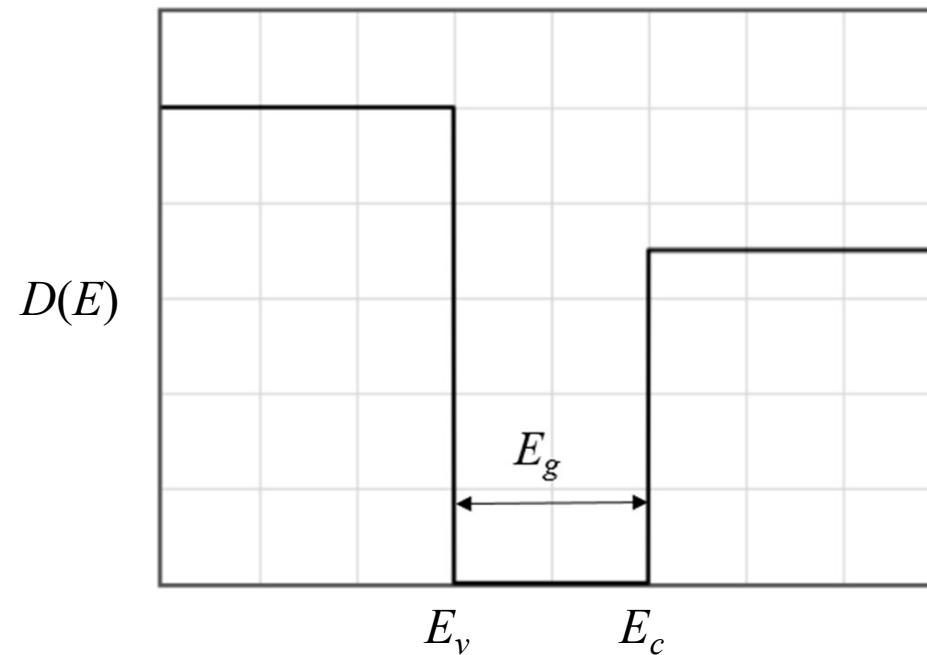
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# Semiconductors and insulators - 2d

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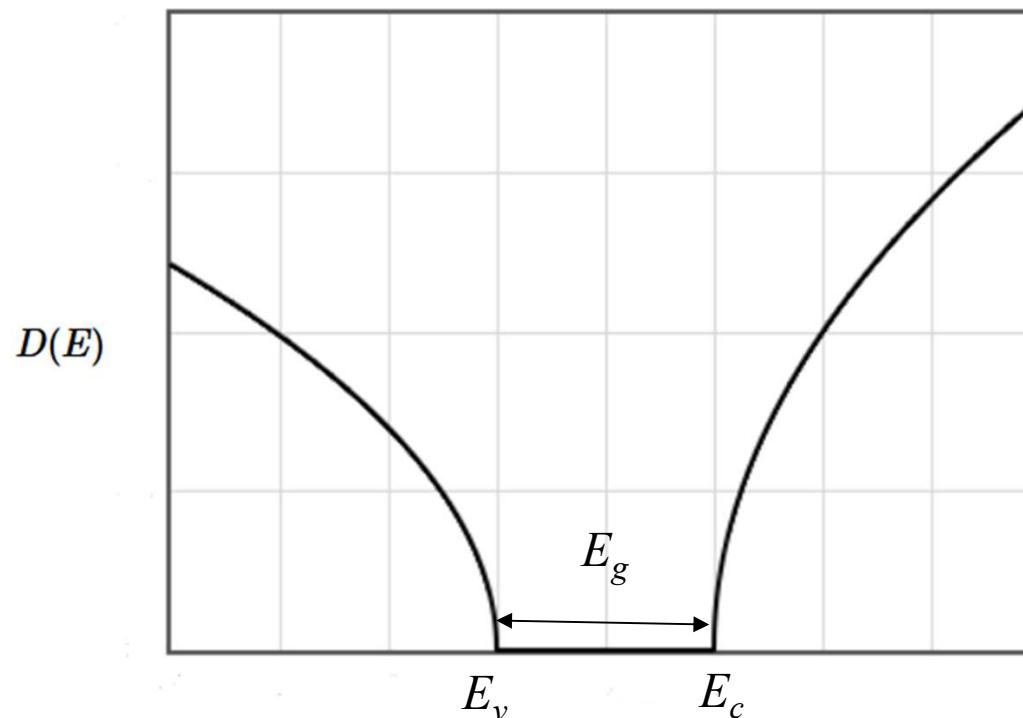
$$D(E) = \begin{cases} D_c & E < E_v \\ 0 & E_v < E < E_c \\ D_v & E_c < E \end{cases} \text{ J}^{-1}\text{m}^{-3}$$



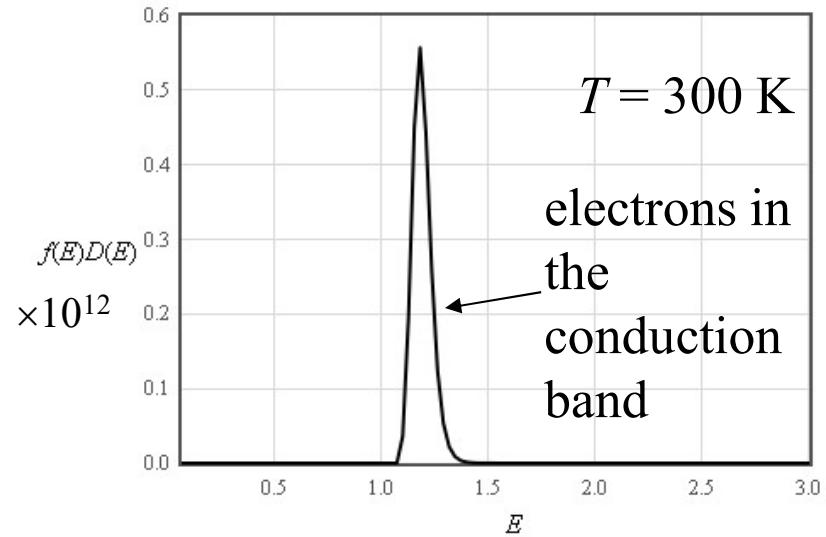
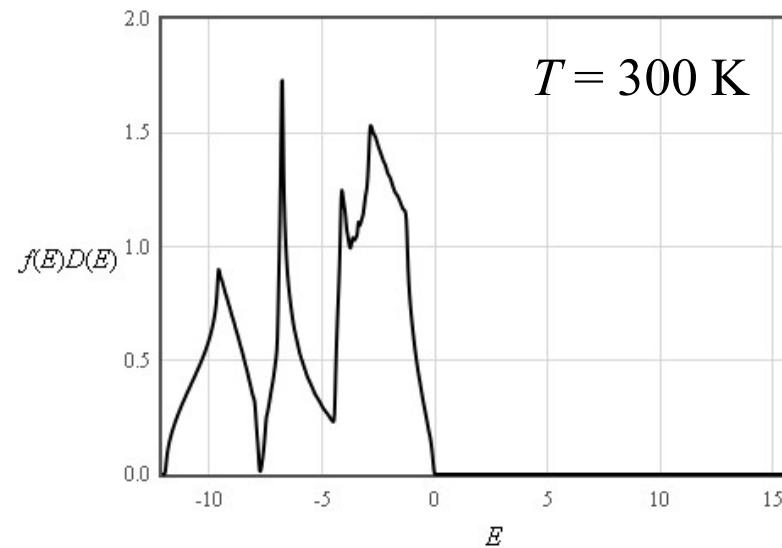
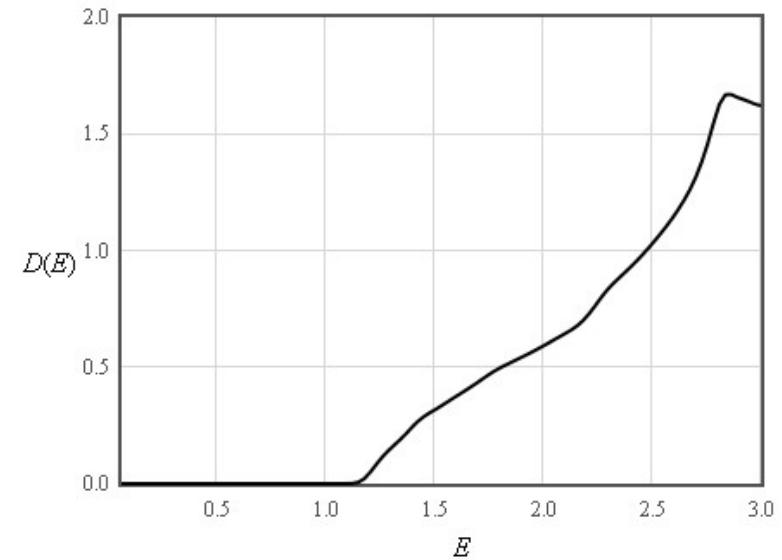
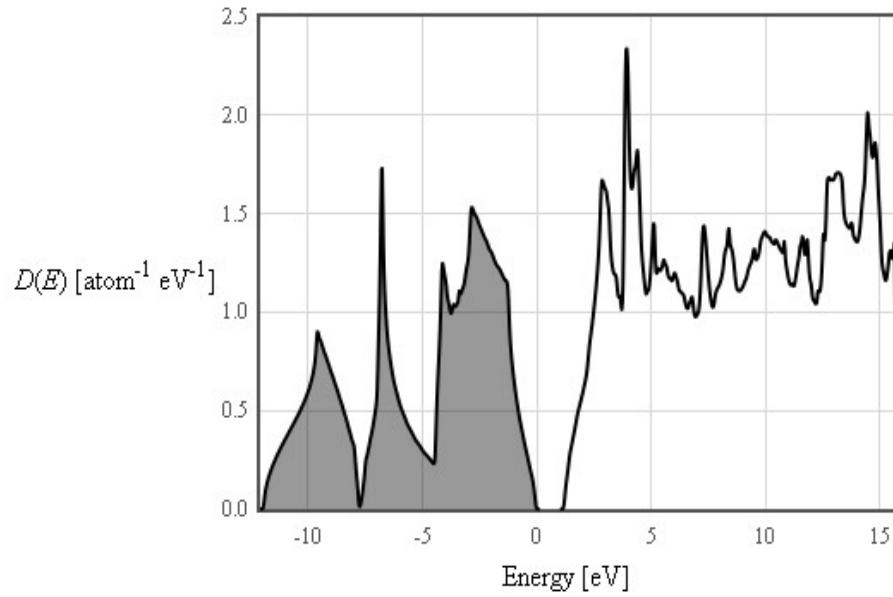
# Semiconductors and insulators - 3d

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$$D(E) = \begin{cases} D_c \sqrt{E_v - E} & E < E_v \\ 0 & E_v < E < E_c \\ D_v \sqrt{E - E_c} & E_c < E \end{cases} \text{ J}^{-1}\text{m}^{-3}$$



# Silicon density of states



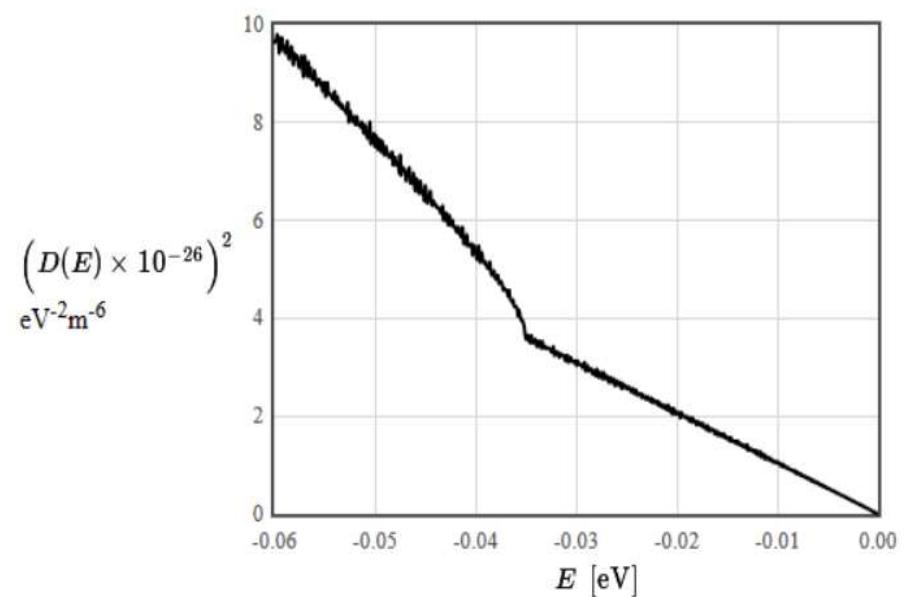
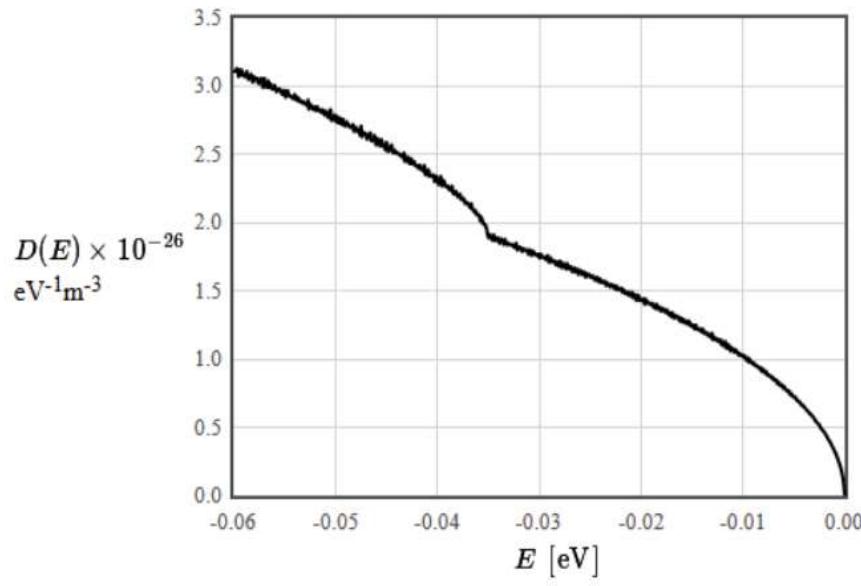
# Silicon valence bands

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$$E_{v,lh} = -\frac{\hbar^2}{2m_e} \left( 4.1k^2 - \sqrt{1.21k^4 + 4.1(k_x^2k_y^2 + k_x^2k_z^2 + k_y^2k_z^2)} \right),$$

$$E_{v,hh} = -\frac{\hbar^2}{2m_e} \left( 4.1k^2 + \sqrt{1.21k^4 + 4.1(k_x^2k_y^2 + k_x^2k_z^2 + k_y^2k_z^2)} \right),$$

$$E_{v,so} = -E_{so} - \frac{\hbar^2 k^2}{2m_{so}}.$$



# Boltzmann Approximation

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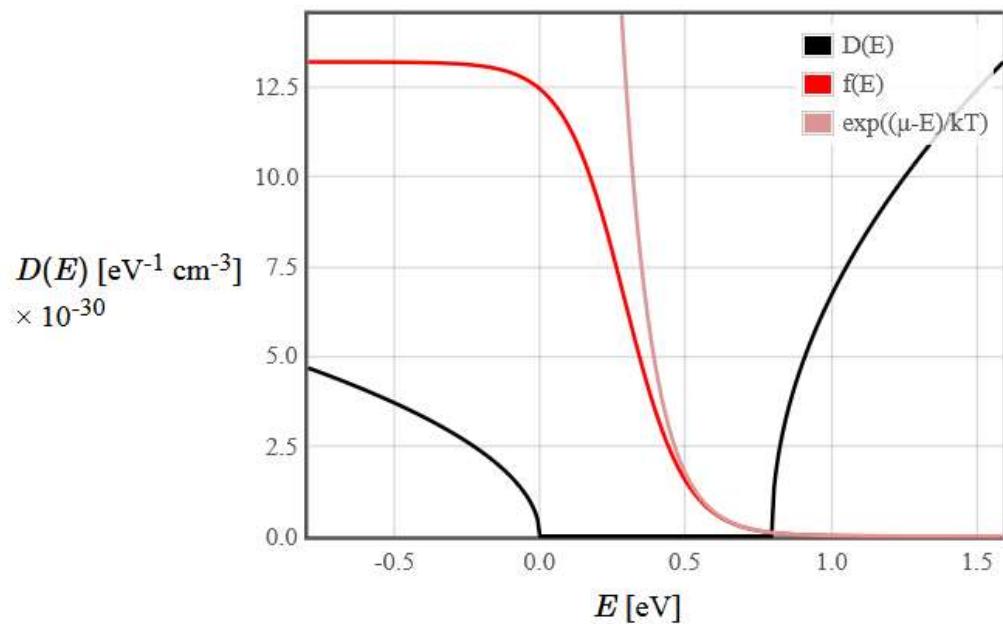
# Density of electrons in the conduction band

The free electron density of states is modified by the effective mass.

$$D(E) = D_c \sqrt{E - E_c}$$

$$f(E) = \frac{1}{1 + \exp\left(\frac{E - \mu}{k_B T}\right)} \approx \exp\left(\frac{\mu - E}{k_B T}\right)$$

Boltzmann  
approximation  
 $E_c - \mu > 3k_B T$



$$n = \int_{E_c}^{\infty} D(E) f(E) dE \approx D_c \int_{E_c}^{\infty} \exp\left(\frac{\mu - E}{k_B T}\right) \sqrt{E - E_c} dE$$

# Density of electrons in the conduction band

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$$n = \int_{E_c}^{\infty} D(E) f(E) dE \approx D_c \int_{E_c}^{\infty} \exp\left(\frac{\mu - E}{k_B T}\right) \sqrt{E - E_c} dE$$
$$= D_c \exp\left(\frac{\mu - E_c}{k_B T}\right) \int_{E_c}^{\infty} \exp\left(-\frac{E - E_c}{k_B T}\right) \sqrt{E - E_c} dE$$

$$x = E - E_c \quad \int_0^{\infty} \sqrt{x} \exp\left(\frac{-x}{k_B T}\right) dx = \frac{2}{\sqrt{\pi}} (k_B T)^{3/2}$$

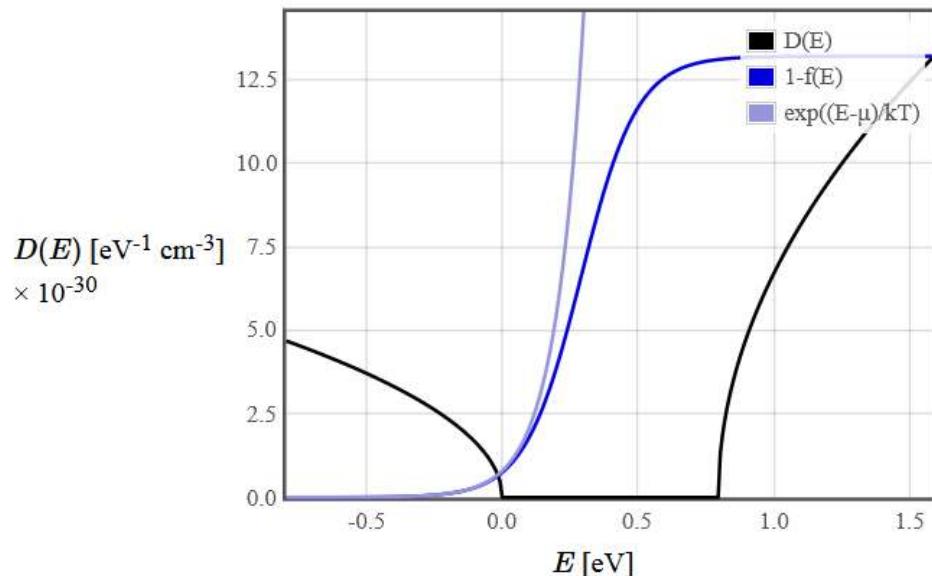
$$n = N_c(T) \exp\left(\frac{\mu - E_c}{k_B T}\right) = \frac{2D_c}{\sqrt{\pi}} (k_B T)^{3/2} \exp\left(\frac{\mu - E_c}{k_B T}\right)$$

$$N_c = \frac{2D_c}{\sqrt{\pi}} (k_B T)^{3/2} = 2 \left( \frac{m^* k_B T}{2\pi\hbar^2} \right)^{3/2} = \text{effective density of states}$$

# Density of holes in the valence band

$$D(E) = D_v \sqrt{E_v - E}$$

$$1 - f(E) = 1 - \frac{1}{1 + \exp\left(\frac{E - \mu}{k_B T}\right)} \approx \exp\left(\frac{E - \mu}{k_B T}\right)$$

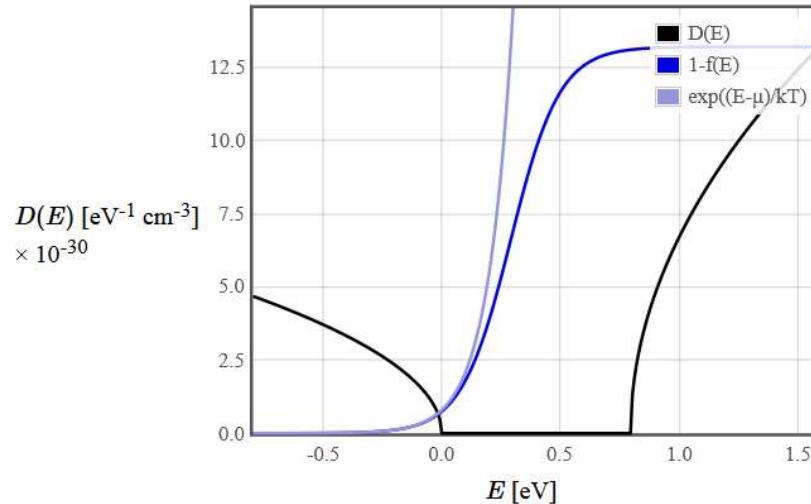


Boltzmann  
approximation  
 $\mu - E_v > 3k_B T$

$$p = \int_{-\infty}^{E_v} D(E)(1 - f(E)) dE \approx D_v \int_{-\infty}^{E_v} \exp\left(\frac{E - \mu}{k_B T}\right) \sqrt{E_v - E} dE$$

# Density of holes in the valence band

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$$p = \int_{-\infty}^{E_v} D(E)(1-f(E))dE \approx D_v \int_{-\infty}^{E_v} \exp\left(\frac{E-\mu}{k_B T}\right) \sqrt{E_v - E} dE$$

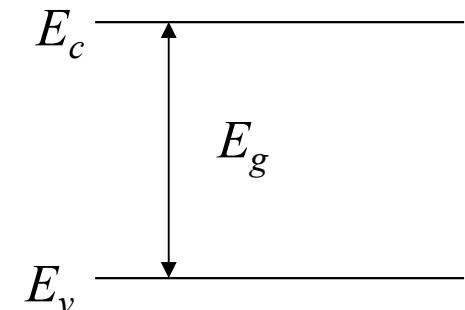
$$\boxed{p = N_v \exp\left(\frac{E_v - \mu}{k_B T}\right)} = \frac{2D_v}{\sqrt{\pi}} (k_B T)^{3/2} \exp\left(\frac{E_v - \mu}{k_B T}\right)$$

$$N_v = 2 \left( \frac{m_h^* k_B T}{2\pi\hbar^2} \right)^{3/2}$$

= Effective density of states in  
the valence band

# Law of mass action

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$$np = N_c \exp\left(\frac{\mu - E_c}{k_B T}\right) N_v \exp\left(\frac{E_v - \mu}{k_B T}\right)$$
$$np = N_c N_v \exp\left(\frac{-E_g}{k_B T}\right)$$


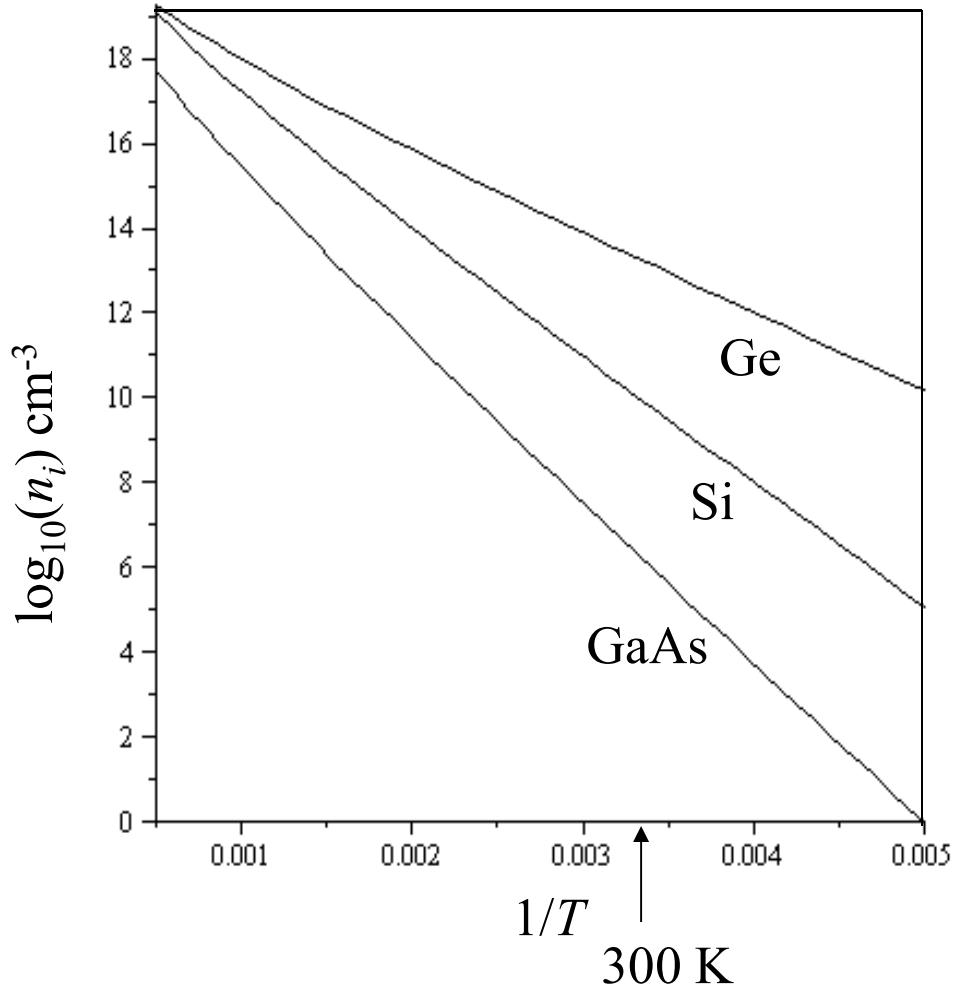
For intrinsic semiconductors (no impurities)

$$n = p = n_i = \sqrt{N_c N_v} \exp\left(\frac{-E_g}{2k_B T}\right)$$

intrinsic carrier density

# Intrinsic carrier concentration

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$$n_i = \sqrt{N_v N_c \left( \frac{T}{300} \right)^3} \exp\left(-\frac{E_g}{2k_B T}\right)$$

$\sim 5 \times 10^{22} \text{ atoms/cm}^3$

# Chemical potential of an intrinsic semiconductor

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$$n = p = N_c \exp\left(\frac{\mu - E_c}{k_B T}\right) = N_v \exp\left(\frac{E_v - \mu}{k_B T}\right)$$

$$\exp\left(\frac{\mu - E_c - E_v + \mu}{k_B T}\right) = \frac{N_v}{N_c}$$

$$\frac{2\mu}{k_B T} = \frac{E_c + E_v}{k_B T} + \ln\left(\frac{N_v}{N_c}\right)$$

$E_c$  —————  
 $\mu$  -----

$$\boxed{\mu = \frac{E_c + E_v}{2} + \frac{k_B T}{2} \ln\left(\frac{N_v}{N_c}\right)}$$

$E_v$  —————

## Boltzmann approximation

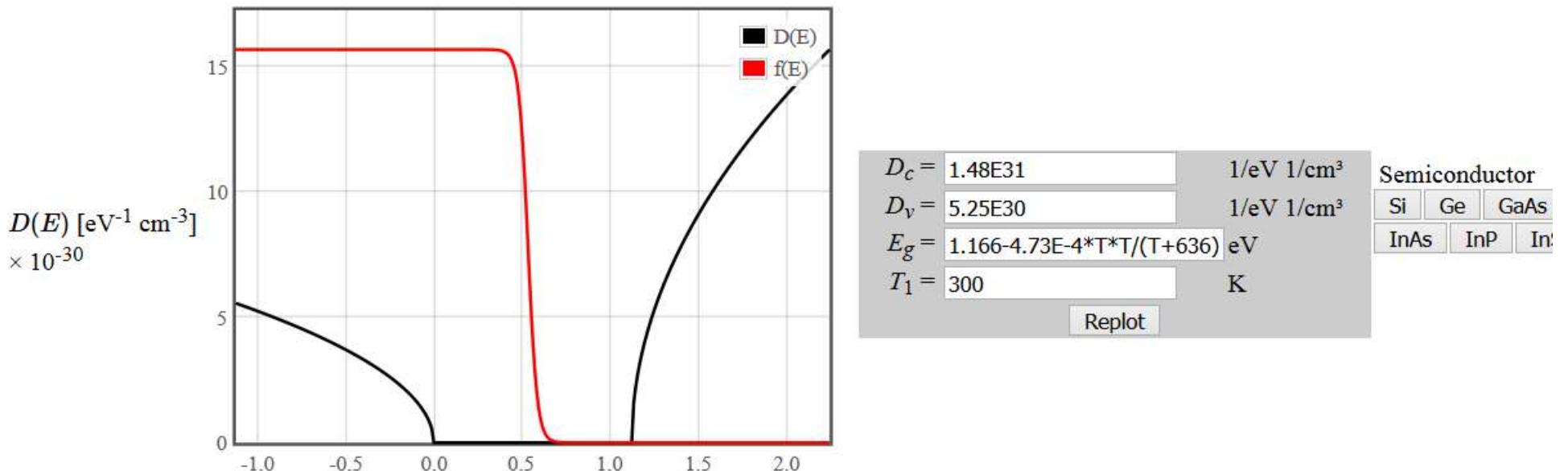
of the valence band and the bottom of the conduction band the density of states of a semiconductor can be approximated as,

$$D(E) = \begin{cases} D_v \sqrt{E_v - E}, & \text{for } E < E_v \\ 0, & \text{for } E_v < E < E_c \\ D_c \sqrt{E - E_c}, & \text{for } E_c < E \end{cases}$$

and  $D_c$  are constants that describe the form of the density of states near the band edges. Often in the literature, these constants are given in terms of the 'masses'  $m_h^*$  and  $m_e^*$  or the 'effective density of states at 300 K'  $N_v(300)$  and  $N_c(300)$ . The relations to  $D_v$  and  $D_c$  are,

$$D_v = \frac{(2m_h^*)^{3/2}}{2\pi^2 \hbar^3} = \frac{\sqrt{\pi} N_v(300)}{2(k_B T)^{3/2}}, \quad D_c = \frac{(2m_e^*)^{3/2}}{2\pi^2 \hbar^3} = \frac{\sqrt{\pi} N_c(300)}{2(k_B T)^{3/2}}.$$

Now shows the density of states of various semiconductors in this approximation. The Fermi function is plotted as well. At low energies the value of the states are occupied. At high energies the Fermi function goes to zero and those states are unoccupied. In the limit of low temperature, the chemical potential gap,  $\mu = E_g/2$ . As the temperature increases, the chemical potential moves towards the band with the lower density of states.



# The electrical contribution to the thermodynamic properties of insulators depend on band edges

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## Boltzmann approximation

The table below gives the contribution of electrons in intrinsic semiconductors and insulators to some thermodynamic quantities. These results were calculated in the Boltzmann approximation where it is assumed that the chemical potential lies in the band gap more than  $3k_B T$  from the band edge. The electronic contribution to the thermodynamic quantities are usually much smaller than the contribution of the phonons and thus the electronic components are often simply ignored.

	1-d	2-d
<b>Density of states</b> $m_e^*$ and $m_h^*$ are 'density of states' effective masses	$D(E) = \begin{cases} \frac{1}{\hbar\pi} \sqrt{\frac{2m_h^*}{(E_\nu - E)}} & E < E_\nu \\ 0 & E_\nu < E < E_c \\ \frac{1}{\hbar\pi} \sqrt{\frac{2m_e^*}{(E - E_c)}} & E > E_c \end{cases} \text{ J}^{-1} \text{ m}^{-1}$	$D(E) = \begin{cases} \frac{m_h^*}{\hbar^2\pi} H(E_\nu - E) & E < E_\nu \\ 0 & E_\nu < E < E_c \\ \frac{m_e^*}{\hbar^2\pi} H(E - E_c) & E > E_c \\ H(x) = 0 \text{ for } x < 0 \text{ and } H(x) = 1 \text{ for } x > 0 & \end{cases} \text{ J}^{-1} \text{ m}^{-2}$
<b>Density of states</b> $N_\nu$ and $N_c$ are the effective densities of states	$D(E) = \begin{cases} N_\nu(300) \sqrt{\frac{2}{300\pi k_B(E_\nu - E)}} & E < E_\nu \\ 0 & E_\nu < E < E_c \\ N_c(300) \sqrt{\frac{2}{300\pi k_B(E - E_c)}} & E > E_c \end{cases} \text{ J}^{-1} \text{ m}^{-1}$	$D(E) = \begin{cases} \frac{N_\nu(300)}{300k_B} H(E_\nu - E) & E < E_\nu \\ 0 & E_\nu < E < E_c \\ \frac{N_c(300)}{300k_B} H(E - E_c) & E > E_c \end{cases} \text{ J}^{-1} \text{ m}^{-2}$
<b>Density of electrons in the conduction band</b> $n = \int_{E_c}^{\infty} D(E)f(E)dE$	$n = \sqrt{\frac{m_e^* k_B T}{\hbar^2 \pi}} \exp\left(\frac{\mu - E_c}{k_B T}\right) \text{ m}^{-1}$ $= N_c \exp\left(\frac{\mu - E_c}{k_B T}\right)$	$n = \frac{m_e^* k_B T}{\hbar^2 \pi} \exp\left(\frac{\mu - E_c}{k_B T}\right) \text{ m}^{-2}$ $= N_c \exp\left(\frac{\mu - E_c}{k_B T}\right)$
<b>Density of holes in the valence band</b> $p = \int_{-\infty}^{E_c} D(E)(1-f(E))dE$	$p = \sqrt{\frac{m_h^* k_B T}{\hbar^2 \pi}} \exp\left(\frac{E_\nu - \mu}{k_B T}\right) \text{ m}^{-1}$ $= N_\nu \exp\left(\frac{\mu - E_c}{k_B T}\right)$	$p = \frac{m_h^* k_B T}{\hbar^2 \pi} \exp\left(\frac{E_\nu - \mu}{k_B T}\right) \text{ m}^{-2}$ $= N_\nu \exp\left(\frac{\mu - E_c}{k_B T}\right)$

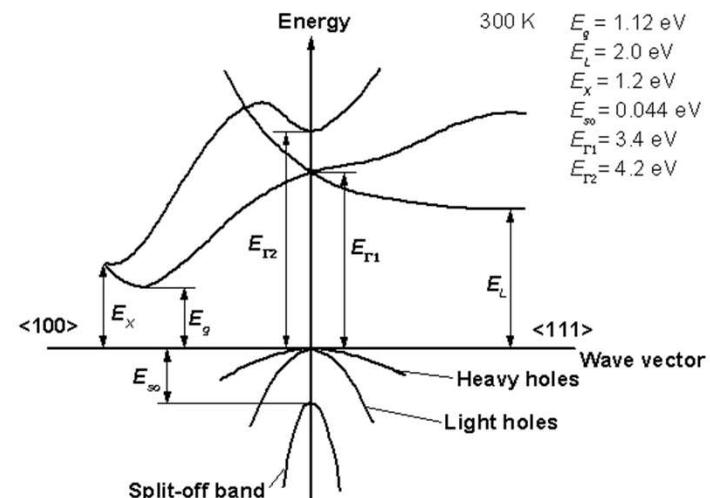
# New Semiconductor Materials. Biology systems.

## Characteristics and Properties

Semiconductors database	n,k InGaAsP	Levels	Equivalents	Bibliografic database
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## NSM Archive - Physical Properties of Semiconductors

Si	- Silicon	Ge	- Germanium
GaP	- Gallium Phosphide	GaAs	- Gallium Arsenide
InAs	- Indium Arsenide	C	- Diamond
GaSb	- Gallium Antimonide	InSb	- Indium Antimonide
InP	- Indium Phosphide	GaAs <sub>1-x</sub> Sb <sub>x</sub>	- Gallium Arsenide Antimonide
Al <sub>x</sub> Ga <sub>1-x</sub> As	- Aluminium Gallium Arsenide		
AlN	- Aluminium Nitride		
BN	- Boron Nitride		



<http://www.matprop.ru/semicond>

## Intrinsic semiconductors

In the Boltzmann approximation, the density of states of a semiconductor is,

$$D(E) = \begin{cases} \frac{(2m_h^*)^{3/2}}{2\pi^2\hbar^3} \sqrt{E_v - E}, & \text{if } E < E_v \\ 0, & \text{if } E_v < E < E_c \\ \frac{(2m_e^*)^{3/2}}{2\pi^2\hbar^3} \sqrt{E - E_c}, & \text{if } E_c < E \end{cases}$$

Here  $m_e^*$  and  $m_h^*$  are the 'density of states effective masses' for electrons and holes. Usually in the literature, effective density of states at 300 K is given instead of the 'density of states effective masses'. The relationship between the two is,

$$m_h^* = \frac{\pi\hbar^2}{300k_B} \left( \sqrt{2}N_v(300) \right)^{2/3}$$

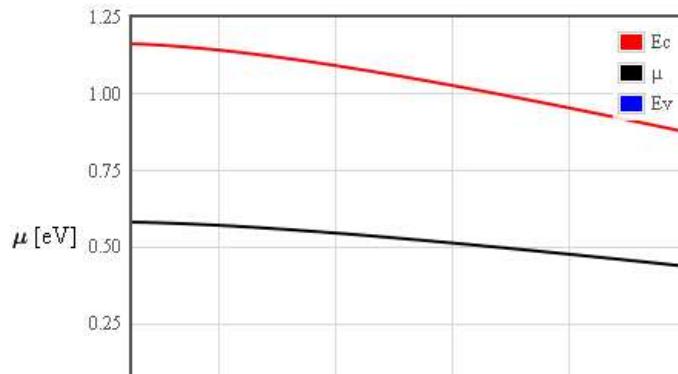
$$m_e^* = \frac{\pi\hbar^2}{300k_B} \left( \sqrt{2}N_c(300) \right)^{2/3}$$

In an intrinsic semiconductor, the density of electrons equals the density of holes,  $n = p = n_i = \sqrt{N_c \left( \frac{T}{300} \right)^{3/2} N_v \left( \frac{T}{300} \right)^{3/2}} \exp\left(\frac{-E_g}{2k_B T}\right)$ .

By setting the concentration of electrons equal to the concentration of holes, it is possible to solve for the chemical potential. The bandgap of most semiconductors is temperature dependent. The form below lets you input the temperature dependence of the bandgap. The bandgaps for some semiconductors can be loaded into the form with the buttons on the right.

$$n = N_c(300) \left( \frac{T}{300} \right)^{3/2} \exp\left(\frac{\mu - E_c}{k_B T}\right) = p = N_v(300) \left( \frac{T}{300} \right)^{3/2} \exp\left(\frac{E_v - \mu}{k_B T}\right)$$

$$\mu = \frac{E_v + E_c}{2} + k_B T \ln\left(\frac{N_v(300)}{N_c(300)}\right)$$



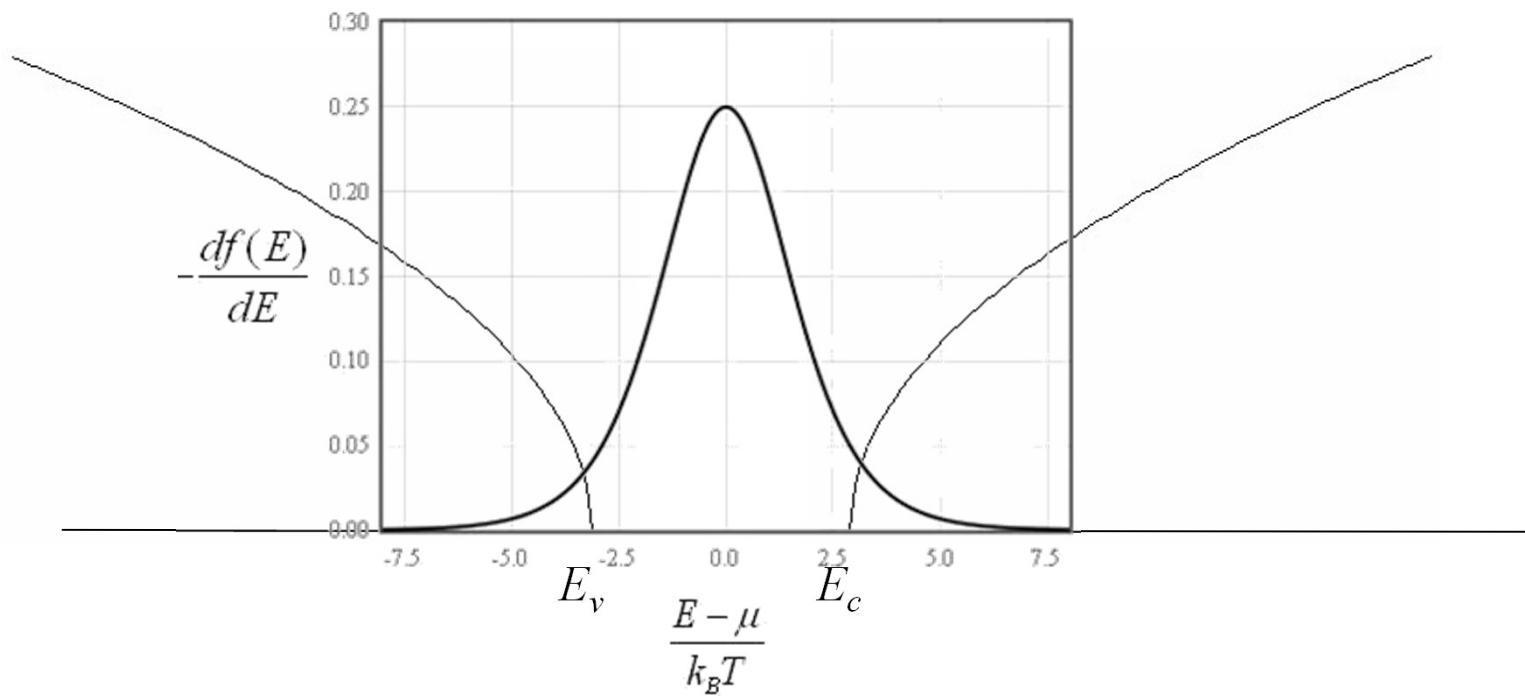
$N_c(300 \text{ K}) =$	2.78E19	1/cm <sup>3</sup>
$N_v(300 \text{ K}) =$	9.84E18	1/cm <sup>3</sup>
$E_g =$	1.166-4.73E-4*T*T/(T+636)	eV
$T_1 =$	50	K
$T_2 =$	1000	K

Replot

Semiconductor  
Si   Ge   GaAs

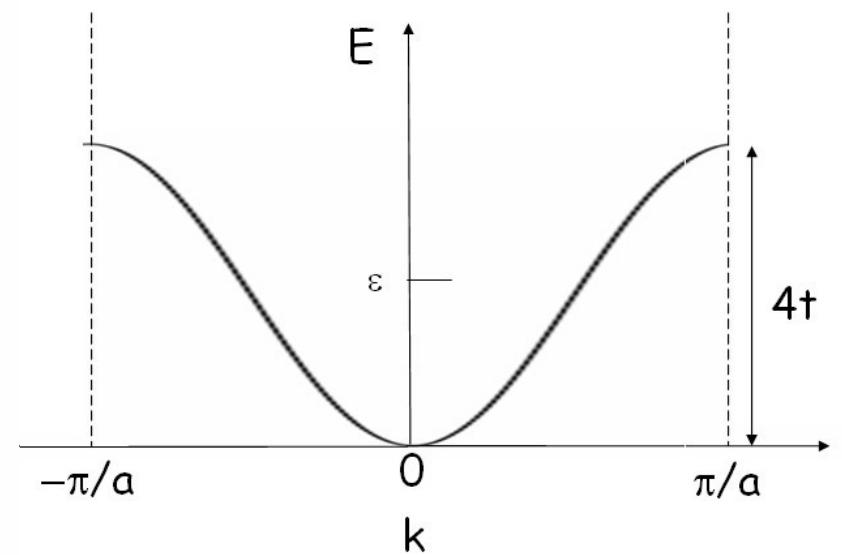
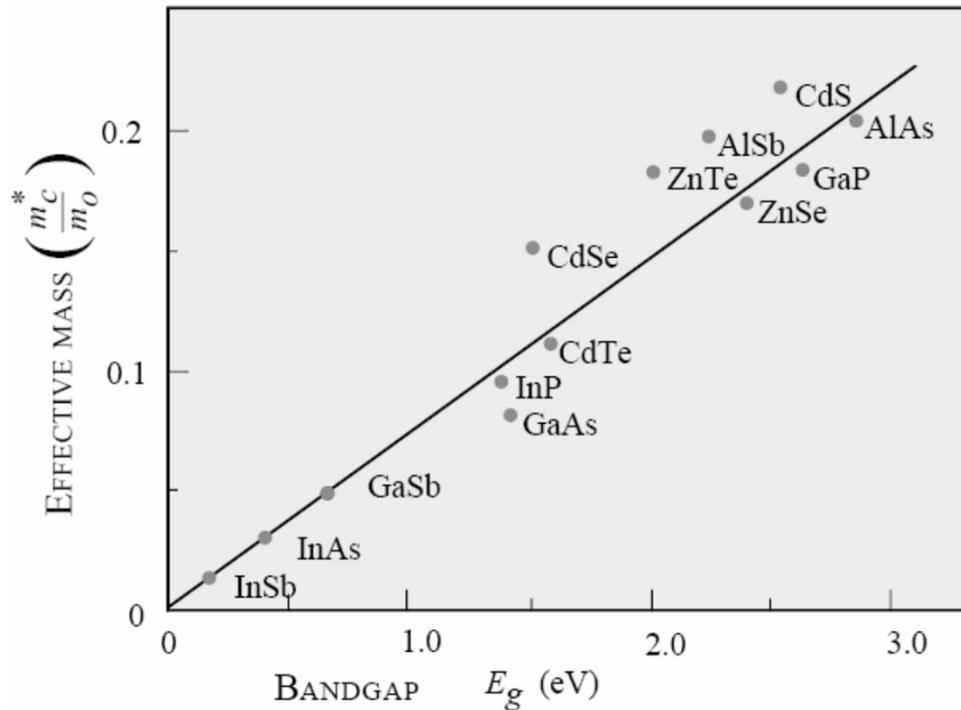
# Narrow bandgap semiconductors

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Use the programs for metals for small bandgap semiconductors.

# Large gap -> large effective mass



$$E_k = \varepsilon - 2t \cos(ka)$$

$$m^* = \frac{\hbar^2}{d^2 E} \frac{1}{dk^2}$$

narrow bands -> large effective mass

$$\frac{d^2 E}{dk^2} = 2ta^2$$

$$m^* \square \frac{1}{t}$$

## 513.160 Microelectronics and Micromechanics

# Silicon

Silicon is the second most common element in the earth's crust and an important semiconducting material.

## Structural properties

Crystal structure: Diamond

Bravais lattice: face centered cubic

Space group: 227 (F d -3 m), Strukturbericht: A4, Pearson symbol: cF8

Point group: m3m ( $O_h$ ) six 2-fold rotations, four 3-fold rotations, three 4-fold rotations, nine mirror planes, inversion

Lattice constant:  $a = 0.543 \text{ nm}$

Atomic weight 28.09

Atomic density  $n_{atoms} = 4.995 \times 10^{22} \text{ 1/cm}^3$

Density  $\rho = 2.33 \text{ g/cm}^3$

Density of surface atoms

(100)  $6.78 \times 10^{14} \text{ 1/cm}^2$

(110)  $9.59 \times 10^{14} \text{ 1/cm}^2$

(111)  $7.83 \times 10^{14} \text{ 1/cm}^2$

